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31046 U.S. PTO
10/042570
01/09/02

5CH-925

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10042570	FILING DATE 01/09/2002	CLASS 359	SUBCLASS 3	GAU 2873	EXAMINER KUNEMULVD
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**APPLICANTS: Tsou Der-Hou; Wu Shang-Yi; Chen Ming-Heng; Chou Ming-Hsien;

**CONTINUING DATA VERIFIED:
None

** FOREIGN APPLICATIONS VERIFIED:
None

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO HC01-001
35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		
Verified and Acknowledged Examiners's initials <i>FL</i>		
TITLE : Method of forming high quality waveguides by vapor-phase proton-exchange process with post-thermal annealing and reversed proton-exchange		

NOTICE OF ALLOWANCE MAILED		Assistant Examiner		CLAIMS ALLOWED	
				Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner		DRAWING	
Amount Due	Date Paid			Sheets Drwg.	Figs.Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE		Application Examiner	
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